

Change to Nd:YAG Lasers

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Process for Making Working Decision to Change Lasers

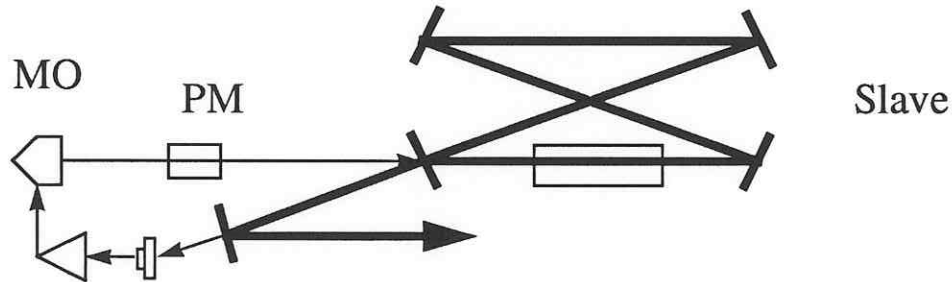
- Discussion of Issues and Questions at Science/Integration Meeting in May
- Report on Technical Comparison / Status and Plans of Other Groups -- August
- Special Meeting of Science Team to Discuss Report and Options for Change -- August
- Working Decision Announced by Barish -- September
- Formal Action by Change Control Board to be Taken When Plans Advance Enough to Fully Assess Technical, Cost, and Schedule Impact

Reasons for Changing Lasers

- Growing Maturity of Diode-Pumped Nd:YAG
 - ›› High Volume OEM Products with Power and Reliability Required for Initial LIGO Detectors
 - ›› Demonstrations of Performance at Stanford, VIRGO, GEO
- Expectation of Future Laser Improvements Gives Path for Enhanced Detectors
 - ›› 100 W Class Single Frequency Lasers Under Development
 - ›› Kilowatt Diode-Pumped Lasers Demonstrated
- Benefits Due to Longer Wavelength
 - ›› Higher Frequency Modulators
 - ›› Higher Power Photodetectors
 - ›› Lower Scatter, Lower Contamination on Optics (?)
- Benefits of Sharing Technology with Other GW Groups

Laser Configuration for Initial Detectors

- Requires 10 W IR Power to Replace 5 W Argon Laser -- Available in Commercial Products
- Injection-Locked Oscillator



- + Slave Reproduces Properties Of Master Oscillator
 - + Demonstrated with Nd:YAG at Stanford, VIRGO, GEO
 - + No Lossy Tuning Elements In Slave
 - Requires One (Simple) Additional Locking Circuit
- Master Oscillator/Power Amplifier
 - + No Locking Required
 - Possible Loss of Efficiency

Master Oscillator

- Both Configurations Allow Near-Term Tests at ~1 W Level with Stabilized Master Oscillator
- Master Oscillator Performance
 - ›› Frequency Noise $< 200 \text{ Hz/Hz}^{-1/2}$ at 100 Hz (100x Better than Argon Laser)
 - ›› Intensity Noise $< 10^{-5} \text{ 1/Hz}^{-1/2}$ above 100 Hz
 - ›› Shot-noise-limited above ~10 MHz
- Options for Master Oscillator
 - ›› Lightwave Electronics (700 mW, Single-Frequency, Integrated Frequency Control, Built-in Relaxation Oscillation Suppression)
 - ›› Laser Zentrum Hannover (up to 1W, Single-Frequency, Integrated Frequency Control, Built-in Relaxation Oscillation Suppression)

Impact on R&D Activities

- Plans Still Preliminary Due to Procurement Uncertainties
- Phase Noise Interferometer
 - ›› Most Stringent Test of Laser Properties (Frequency, Intensity Stability)
 - ›› Highest Priority for 10 W Laser When Available
 - ›› Convert to Near-IR as Soon as Optics and MO Laser Are Available (4-6 Months?)
 - ›› Will Proceed with Green Recycling in Interim
- 40 m Interferometer
 - ›› Most Near-term Tasks Independent of Wavelength (New Test Mass Suspension, Recycling Controls Test)
 - ›› Will Defer Installation of 12m Suspended Mode Cleaner (To Be Used for Nd:YAG Laser Tests)
 - ›› Procure Optics and MO Laser for Conversion in 1996

Impact on Detector Design and Plans

- Laser Development
 - ›› Work with Industry, Other GW Groups to Develop Laser
 - ›› Repeat Stabilization Design and Testing
 - ›› Gain Immediate Experience with Stabilization of MO
- Impact on Other Detector Subsystems
 - ›› Interferometer Configuration: Modulation Frequencies
 - ›› Optical Layout: Increased Beam Clearances
 - ›› Optics: Substrates, Coating Uniformity, Metrology
 - ›› Suspension Design: Optics Size
 - ›› I/O Optics: Beam Sizes, Telescopes
 - ›› Photodetectors, Modulators

Minimal Impact on Facilities Design

- Beam Tube
 - ›› Diameter Already Sized to Accommodate Multiple IR Beams
 - ›› Baffle Performance Required for Visible and Near-IR, Independent of Initial Interferometer Choice
- Vacuum Equipment
 - ›› No Major Impact
- Buildings
 - ›› Ultimate Power Requirements for Advanced Solid-State Lasers (100+ W Class) ~ Same as Initial Argon Lasers
 - ›› Can Defer Installation of Chiller Plant Module, Some Cooling Distribution Lines